

Applicant : Eiji Nishibe et al.  
Serial No. : 09/944,452  
Filed : August 31, 2001  
Page : 2 of 10

Attorney's Docket No.: 10417-  
093001 / F51/137275M/TOM

Amendments to the Specification:

Please replace the title beginning at page 1, line 1 as with the following amended title:

Semiconductor Device and Manufacturing ~~Method Thereof~~ Using One Element

Separation Film